

United States Patent and Trademark Office

UNITED STATES DEPARTMENT OF COMMERCE United States Patent and Trademark Office Address: COMMISSIONER FOR PATENTS P.O. Box 1450 Alexandria, Vignia 22313-1450 www.uspto.gov

APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO
09/421,043	10/20/1999	TOSHIO MASUDA	503.34403VP2	3576
20457 7	7590 08/13/2003			
ANTONELLI, TERRY, STOUT & KRAUS, LLP 1300 NORTH SEVENTEENTH STREET SUITE 1800			EXAMINER	
			ALEJANDRO MULERO, LUZ L	
ARLINGTON,	, VA 22209-9889		ART UNIT	PAPER NUMBER
		•	1763	
			DATE MAILED: 08/13/2003	

Please find below and/or attached an Office communication concerning this application or proceeding.

·		B			
	Application No.	Applicant(s)			
0.55	09/421,043	MASUDA ET AL.			
Office Action Summary	Examiner	Art Unit			
	Luz L. Alejandro	1763			
The MAILING DATE of this communication Period for Reply	n appears on the cover sheet with	the correspondence address			
A SHORTENED STATUTORY PERIOD FOR R THE MAILING DATE OF THIS COMMUNICATI - Extensions of time may be available under the provisions of 37 C after SIX (6) MONTHS from the mailing date of this communicati - If the period for reply specified above is less than thirty (30) days - If NO period for reply is specified above, the maximum statutory - Failure to reply within the set or extended period for reply will, by - Any reply received by the Office later than three months after the earned patent term adjustment. See 37 CFR 1.704(b). Status 1) Responsive to communication(s) filed or	ON. FR 1.136(a). In no event, however, may a replyon. , a reply within the statutory minimum of thirty (3 period will apply and will expire SIX (6) MONTH statute, cause the application to become ABAN mailing date of this communication, even if time	y be timely filed 30) days will be considered timely. S from the mailing date of this communication. IDONED (35 U.S.C. § 133).			
2a)⊡ This action is FINAL . 2b)⊠	This action is non-final.				
3) Since this application is in condition for allowance except for formal matters, prosecution as to the merits is closed in accordance with the practice under <i>Ex parte Quayle</i> , 1935 C.D. 11, 453 O.G. 213. Disposition of Claims					
4)⊠ Claim(s) <u>52-61</u> is/are pending in the appl	ication.				
4a) Of the above claim(s) is/are withdrawn from consideration.					
5) Claim(s) is/are allowed.					
6)⊠ Claim(s) <u>52-61</u> is/are rejected.					
7) Claim(s) is/are objected to.					
8) Claim(s) are subject to restriction a Application Papers	and/or election requirement.				
9)☐ The specification is objected to by the Exa	miner.				
10) The drawing(s) filed on is/are: a) accepted or b) objected to by the Examiner.					
Applicant may not request that any objection to the drawing(s) be held in abeyance. See 37 CFR 1.85(a).					
11)☐ The proposed drawing correction filed on is: a)☐ approved b)☐ disapproved by the Examiner.					
If approved, corrected drawings are required in reply to this Office action.					
12)☐ The oath or declaration is objected to by the Examiner.					
Priority under 35 U.S.C. §§ 119 and 120					
13) Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f).					
a) ☐ All b) ☐ Some * c) ☐ None of:					
1. Certified copies of the priority documents have been received.					
2. Certified copies of the priority documents have been received in Application No					
3. Copies of the certified copies of the priority documents have been received in this National Stage application from the International Bureau (PCT Rule 17.2(a)). *See the attached detailed-Office action for a list of the certified copies not received.					
14)☐ Acknowledgment is made of a claim for do	mestic priority under 35 U.S.C. §	119(e) (to a provisional application).			
a) ☐ The translation of the foreign languag 15)☐ Acknowledgment is made of a claim for do	• • • • • • • • • • • • • • • • • • • •				
Attachment(s)					
1) Notice of References Cited (PTO-892) 2) Notice of Draftsperson's Patent Drawing Review (PTO-94 3) Information Disclosure Statement(s) (PTO-1449) Paper N	8) 5) Notice of Info	mmary (PTO-413) Paper No(s) ormal Patent Application (PTO-152)			
J.S. Patent and Trademark Office PTO-326 (Rev. 04-01) Offi	ce Action Summary	Part of Paper No. 29			

Application/Control Number: 09/421,043

Art Unit: 1763

DETAILED ACTION

Claim Objections

Claim 52 objected to because of the following informalities: at line 13, before "temperature", -- the – should be inserted for proper grammar. Appropriate correction is required.

Claim Rejections - 35 USC § 103

The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:

(a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.

This application currently names joint inventors. In considering patentability of the claims under 35 U.S.C. 103(a), the examiner presumes that the subject matter of the various claims was commonly owned at the time any inventions covered therein were made absent any evidence to the contrary. Applicant is advised of the obligation under 37 CFR 1.56 to point out the inventor and invention dates of each claim that was not commonly owned at the time a later invention was made in order for the examiner to consider the applicability of 35 U.S.C. 103(c) and potential 35 U.S.C. 102(e), (f) or (g) prior art under 35 U.S.C. 103(a).

Claims 52-61 are rejected under 35 U.S.C. 103(a) as being unpatentable over Tsuji et al., JP 4-214873 in view of Shinji, JP 9-275092 and Ishioka, JP3-104222.

Application/Control Number: 09/421,043 Page 3

Art Unit: 1763

Tsuji et al. shows the invention substantially as claimed including a plasma apparatus in which a gas is supplied to a metal chamber and a sample 10 which is placed on a sample holder 11 disposed inside of the chamber is processed by a plasma generated in the chamber, the apparatus comprising: a power source 13 for supplying a high frequency wave to the sample holder; an aluminum member 20 held against the sidewall inside of the chamber and forming an inner surface of the chamber which is contact with the plasma generated in the chamber (see fig. 1); and a thermally conductive medium 21B being circulated inside of the member so as to control the temperature of the member within a predetermined range, wherein the thermally conductive medium is a coolant (see, for example, paragraphs 0032 and fig. 1).

Tsuji et al. does not expressly disclose that the member 20 is detachable. Shinji discloses a plasma apparatus comprising a member 12 that is detachably attached to the chamber in order to be easily removable, therefore, reducing the cleaning time of the apparatus (see paragraph 0005). Also, Ishioka discloses a plasma apparatus comprising a removable shield 17 for enabling removing of the shield during maintenance and management of the system (see page 7-first paragraph, and fig. 2). Therefore, in view of these disclosures, it would have been obvious to one having ordinary skill in the art at the time the invention was made to modify the apparatus of Tsuji et al. as to comprise a detachable member because in such a way maintenance and management of the apparatus is more easily performed, and the cleaning time of the apparatus is reduce.

Page 4

Application/Control Number: 09/421,043

Art Unit: 1763

With respect to the chamber being at least partially constituted by a sidewall which is grounded to earth, Shinji discloses that the plasma chamber is grounded. It is also known in the art that electrical floating is prevented by grounding the chamber. Therefore, it would have been obvious to one having ordinary skill in the art at the time the invention was made to modify the apparatus of Tsuji et al. as to ground a sidewall of the chamber in order to prevent the chamber from being electrically floating, which can alter the process conditions, thereby, ensuring repeatability of the wafers being processed.

With respect to: a) the apparatus being a plasma etching apparatus, b) the surface of the member being controlled to a temperature lower than a temperature of the sample, c) the thermally conductive medium being circulated as to control the temperature of the surface of the member in the claimed range, and d) the thickness of the film formed on the member, such limitations are directed to method limitations instead of apparatus limitations, and since an apparatus is being claimed as the instant invention, the method teachings are not considered to be the matter at hand, since a variety of methods can be done with the apparatus. The method limitations are viewed as intended uses that do not further limit, and therefore do not patentably distinguish the claimed invention. The apparatus of Tsuji et al. modified by Shinji and Ishioka is capable of being used for an etching process, being used to control the temperature of the member as claimed, and to form a film of the claimed thickness on the member.

Art Unit: 1763

Response to Arguments

Applicant's arguments with respect to claims 52-61 have been considered but are most in view of the new ground(s) of rejection.

Conclusion

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Luz L. Alejandro whose telephone number is 703-305-4545. The examiner can normally be reached on Monday to Thursday from 7:30 to 6:00.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Gregory L. Mills can be reached on 703-308-1633. The fax phone numbers for the organization where this application or proceeding is assigned are 703-872-9310 for regular communications and 703-872-9311 for After Final communications.

Any inquiry of a general nature or relating to the status of this application or proceeding should be directed to the receptionist whose telephone number is 703-308-0661.

Luz L. Alejandro Primary Examiner Page 5

Art Unit 1763

August 11, 2003